



PATENT  
Customer Number 22,852  
Attorney Docket No. 07553.0044

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Hideki TANAKA ) Group Art Unit: 2878  
)  
Application No. 10/644,745 ) Examiner:  
)  
Filed: August 21, 2003 ) Confirmation No.: 6213  
)  
For: PLASMA LEAK MONITORING )  
METHOD, PLASMA )  
PROCESSING APPARATUS AND )  
PLASMA PROCESSING METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**TRANSMITTAL OF SUBSTITUTE DECLARATION**

Attached is a Substitute Declaration for filing in the U.S. Patent and Trademark Office in the above-identified patent application.

The Substitute Declaration is being filed because the declaration filed with the Notice to File Missing Parts on December 15, 2003 did not reflect the application serial number and filing date.

The Commissioner is hereby authorized to charge any fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

If there are any fees due in connection with the filing of this Substitute Declaration, please charge the fees to our Deposit Account No. 06-0916. If a fee is

required for an extension of time under 37 C.F.R. § 1.136 not accounted for above, such an extension is requested and the fee should also be charged to our Deposit Account.


Acceptance of this application with its original filing date is requested.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 1, 2005

By:   
David W. Hill  
Reg. No. 28,220